



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
••	:	Examiner: Z. E. Cabrera
Kieji YOSHIMURA)	
	:	Group Art Unit: 2125
Application No.: 09/964,648)	
	:	Confirmation No.: 1952
Filed: September 28, 2001)	
	:	
For: EXPOSURE APPARATUS, SEMICONDUCTOR)	October 30, 2003
DEVICE MANUFACTURING METHOD,	:	
EXPOSURE APPARATUS MAINTENANCE)	
METHOD AND SEMICONDUCTOR	:	RECEIVED
MANUFACTURING FACTORY		NLCLIVLD
		OCT 3 1 2003
Mail Stop Non-Fee Amendment		_
Commissioner for Patents		Technology Center 2100
P.O. Box 1450		0.
Alexandria, VA 22313-1450		

Sir:

Transmitted herewith is an Amendment and Letter Submitting Substitute Specification in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below:

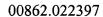
CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	9	MINUS	27	= 0	x \$9 \$18	\$0.00
INDEP. CLAIMS	3	MINUS	10	= 0	x \$43 \$86	\$0.00
Fee for Multiple Dependent claims \$145/\$290						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$0.00

	°Verified Statement claiming small entity status is enclosed, if not filed previously.			
	A check in the amount of \$ is enclosed.			
	Charge \$ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.			
X	Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.			
	A check in the amount of \$ to cover the fee for a month extension is enclosed.			
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.			
X	Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.			
	Respectfully submitted,			
	Attorney for Applicant Steven E. Warner Registration No. 33,326			
EIT7DAT	TDICK CELLA HADDED & SCINITO			

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

SEW/eab

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PATENT APPLICATION

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In re Application of:)	
	:	Examiner: Z. E. Cabrera
Kieji YOSHIMURA)	
	:	Group Art Unit: 2125
Application No.: 09/964,648)	G 5 1 N 1050
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EXPOSURE APPARATUS MAINTENANCE)	RECEIVED
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MANUFACTURING FACTORY)	OCT 3 1 2003
Maria N. D. A. J. A.		Technology Center 2100
Mail Stop Non-Fee Amendment		Toolinology Contain 2100
Commissioner for Patents		
P.O. Box 1450		
Alexandria, VA 22313-1450		

AMENDMENT AND LETTER FORWARDING SUBSTITUTE SPECIFICATION

Sir:

In response to the Official Action dated July 30, 2003, please amend the above-identified application as follows: